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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Ryuichi EBINUMA et al.

Examiner: H. Nguyen

Application No.: 09/817,018

Group Art Unit: 2851

Filed: March 27, 2001

For: SUPPORTING STRUCTURE OF OPTICAL ELEMENT, EXPOSURE APPARATUS

April 24, 2003

HAVING THE SAME, AND MANUFACTURING)
METHOD OF SEMICONDUCTOR DEVICE

Commissioner for Patents Washington, D.C. 20231

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

Further to the Information Disclosure Statement filed on June 21, 2001, in compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed PTO-1449 form. Copies of the listed documents are also enclosed.

Applicants request that the above information be considered by the Examiner and that a copy of the enclosed PTO-1449 form be initialed and returned indicating that such information has been considered.

We also enclose a check for the required fee of \$180.00 to cover the Information Disclosure Statement under 37 C.F.R. 1.97(c)(2). The Commissioner is authorized to charge Deposit Account No. 06-1205 should any other fees be deemed necessary in connection with this paper.

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180.00 OP

Applicants' undersigned attorney may be reached in our Washington D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

Attorney for Applicants
Steven E. Warner
Registration No. 33,326

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza New York, New York 10112-3801 Facsimile: (212) 218-2200

SEW/eab